



3790 USA/DISPLAY/AKT/RK  
7828.7017

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:	)	
KURITA, et al.	)	Group Art Unit: 1763
Serial No. 09/464,362	)	
Filed: December 15, 1999	)	Examiner: McArthur, S.
For: DUAL SUBSTRATE LOADLOCK	)	
PROCESS EQUIPMENT	)	

AMENDMENT

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sirs:

This is in response to the Office Action dated December 18, 2002, which was Paper No. 15 of the present application, the response being due by June 18, 2003 by the enclosed Petition for Extension of Time. Please amend the present application as follows:

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JUN 27 2003  
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